

## Supplementary Information

### Self-poling Piezoelectric Polymer Composites via Melt-state Energy Implantation

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## Supplementary Text

### Phase fraction determination of PVDF

The fraction of  $\beta$ -phase ( $F(\beta)$ ) can be calculated using the following equation<sup>1</sup>:

$$F(\beta) = \frac{A_{\beta}}{\left(\frac{K_{\beta}}{K_{\alpha}}\right) A_{\alpha} + A_{\beta}} \times 100\% \quad (1)$$

Where  $A_{\alpha}$  and  $A_{\beta}$  are the absorbance at 764 and 840  $\text{cm}^{-1}$ , respectively.  $K_{\alpha}$  and  $K_{\beta}$  are the corresponding absorbance coefficients,  $6.1 \times 10^4$  and  $7.7 \times 10^4 \text{ cm}^2 \text{ mol}^{-1}$ , respectively.

The fraction of  $\gamma$ -phase ( $F(\gamma)$ ) can be calculated using the following equations:

$$F(\gamma) = \frac{A_{\gamma}}{\left(\frac{K_{\gamma}}{K_{\alpha}}\right) A_{\alpha} + A_{\gamma}} \times 100\% \quad (2)$$

Where  $A_{\alpha}$  and  $A_{\gamma}$  are the absorbance at 764 and 832  $\text{cm}^{-1}$ , respectively.  $K_{\alpha}$  and  $K_{\gamma}$  are the corresponding absorbance coefficients, 0.365 and 0.150  $\mu\text{m}^{-1}$ , respectively.  $F(\alpha)$  is calculated using  $1 - F(\beta) - F(\gamma)$ .

From these equations, we can see that the characteristic peak of  $\beta$ -phase and  $\gamma$ -phase are 840  $\text{cm}^{-1}$  and 832  $\text{cm}^{-1}$ , which leads to some confusions in distinguishing them. Thus, XRD is usually employed to provide further information of the crystal structures.

## Characterization of crystallinity

### Calculated via DSC

The degree of crystallinity ( $\chi_c$ ) of CP-PBf and EI-PBf samples can be calculated by the following equation:

$$\chi_c = \frac{\Delta H_m}{\Delta H_0} \times 100\% \quad (3)$$

where  $\Delta H_m$  and  $\Delta H_0$  represent melting enthalpies of the present sample and of perfectly crystalline PVDF ( $104.5 \text{ Jg}^{-1}$ )<sup>2,3</sup>, respectively.

### Calculated via XRD

The variations of crystallinity that was calculated from the following equation based on XRD patterns.

$$\chi_c = \frac{S_c}{S_c + S_a} \times 100\% \quad (4)$$

where,  $S_c$  and  $S_a$  represent the sum of areas of crystalline parts and amorphous parts in XRD diffraction peaks, respectively. Peak separation and area calculation were all done through JADE<sup>4</sup>.

## Characterization of d33, g33 and FOM

### Measurement methods

#### Method 1:

PBf sample was used to measure piezoelectric properties. First, we define the two faces of PBf as A and B faces, respectively. Sticking Al electrodes on the A and B surfaces respectively, and then putting a layer of Pi tape on the outside of the sample. Second, the PBf sample with A face up is affixed to the baffle, and the positive and negative electrodes of the source meter are connected to the Al electrode near the hammerhead and away from the hammerhead respectively. Then a certain distance is set between the hammerhead and the PBf sample, and the voltage, current and charge values varying with the force are obtained by applying different forces. Third, attach the PBf sample with B side up to the baffle. Through the same steps, connect the b-facing up PBf sample to the positive and negative poles of the source meter. Separately measure voltage, current and charge values under different forces.

#### Method 2:

The preparation of sample for measurement is same as the method 1. Sticking Al electrodes on the A and B surfaces respectively, and then putting a layer of Pi tape on the outside of the sample. The PBf sample is affixed to the baffle, and the positive and negative electrodes of the source meter are connected to the Al electrode near the hammerhead and away from the hammerhead respectively. Then the hammerhead was controlled move with the force applied on the surface of sample raised from  $\sim 2\text{N}$  to a setting value and then drop back to  $\sim 2\text{N}$ . During measurement, the force and charge values were recorded. And the slope of the charge vs force variations was d33 value.

### Calculation details

Here, we define  $Q_p$  as the piezoelectric charge transfer that induced by PBf sample at a certain force. Through the compressed balance analysis (CBA) method proposed by Zhonglin Wang et al<sup>5</sup>, it is known that in the above-mentioned stage, triboelectric charges and piezoelectric charges are saturated in the compressed stage as well as an electrostatic balance is formed.

Specifically, there is an electrostatic balance between triboelectric charges and piezoelectric charges at the compressed stage.  $Q_2$  is the transferred charge in the Al electrodes,  $-Q_1$  is then

transferred charge in the Kapton layer,  $q$  is the total charge transfer in the electrode which contains both piezoelectric and triboelectric parts,  $Q_p$  is the induced piezoelectric charge.

Therefore, the electrostatic balance relationship formed by the PBF sample with the A face up is:

$$Q_2 - Q_1 + q - Q_p = 0 \quad (5)$$

After flipping the device, the electrostatic balance on B side becomes:

$$Q_2 - Q_1 - q' - Q_p = 0 \quad (6)$$

Where  $-q'$  is the total charge transfer in the electrode.

By making Eq. (5) - Eq. (6):

$$Q_p = \frac{q + q'}{2} \quad (7)$$

The total induced piezoelectric charge  $Q_p$  can be calculated by substituting the values of  $q$  and  $q'$  into expression without considering the interference from triboelectric charges.

The piezoelectric ( $d_{33}$ ) and piezoelectric voltage ( $g_{33}$ ) coefficient are obtained by Eq. (8) and Eq. (9), respectively:

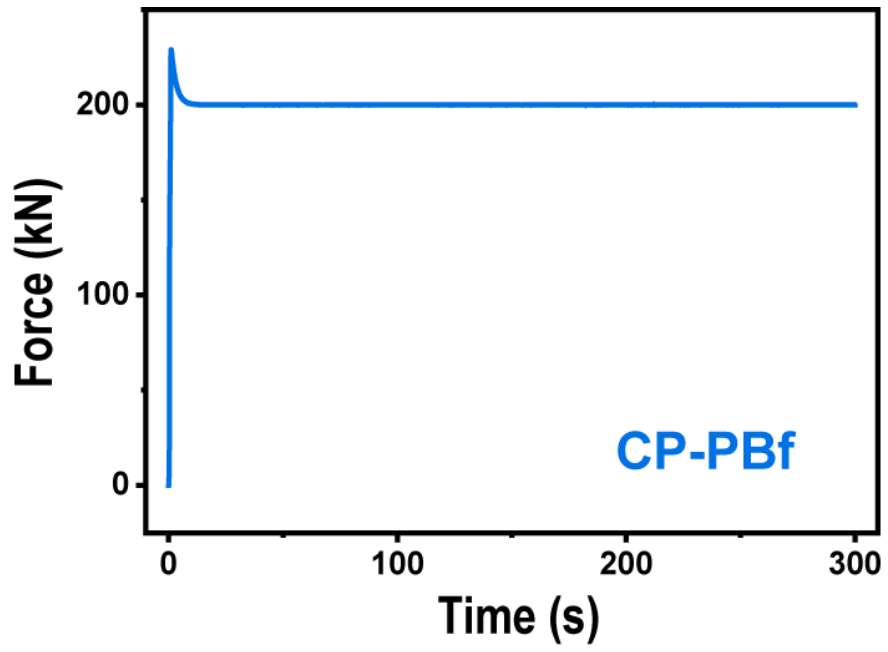
$$d_{33} = \frac{Q_p}{F} \quad (8)$$

Where  $Q_p$  is the induced piezoelectric charge and  $F$  is the applied force.

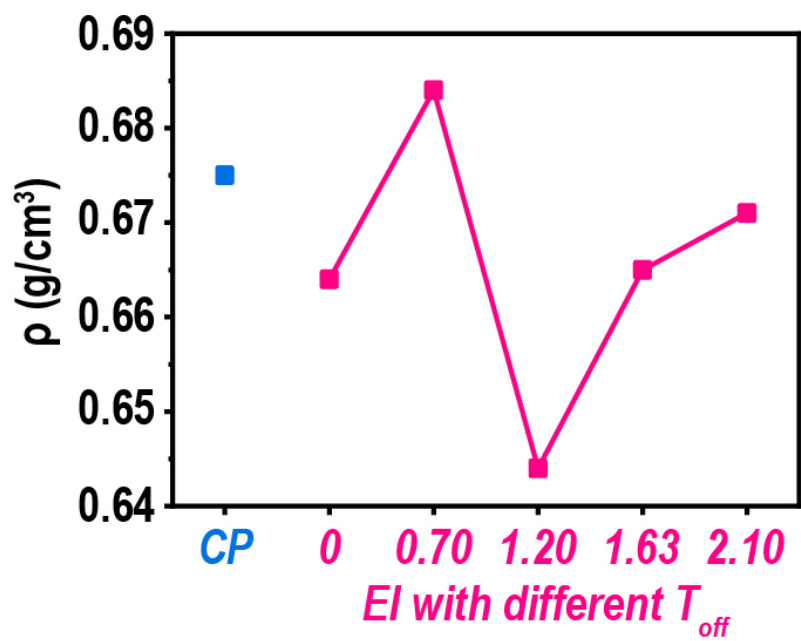
$$g_{33} = \frac{d_{33}}{\epsilon_0 \kappa_{33}} \quad (9)$$

Where  $\epsilon_0 = 8.85 \times 10^{-12}$  F/m is the vacuum permittivity and  $\kappa_{33}$  is relative permittivity. The product of  $d_{33}$  and  $g_{33}$  is generally considered to represent the Figof merit (FOM) for piezoelectric energy harvesters and sensors, which can be read as follows:

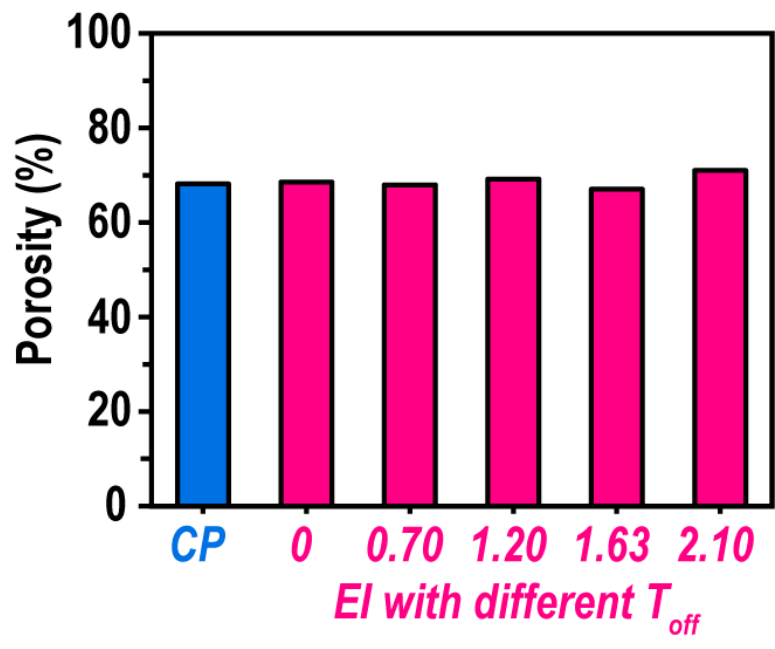
$$FOM = d_{33} \times g_{33} \quad (10)$$



**Supplementary Fig. 1.** Pressure-time relationship for compression molding CP-PBf.

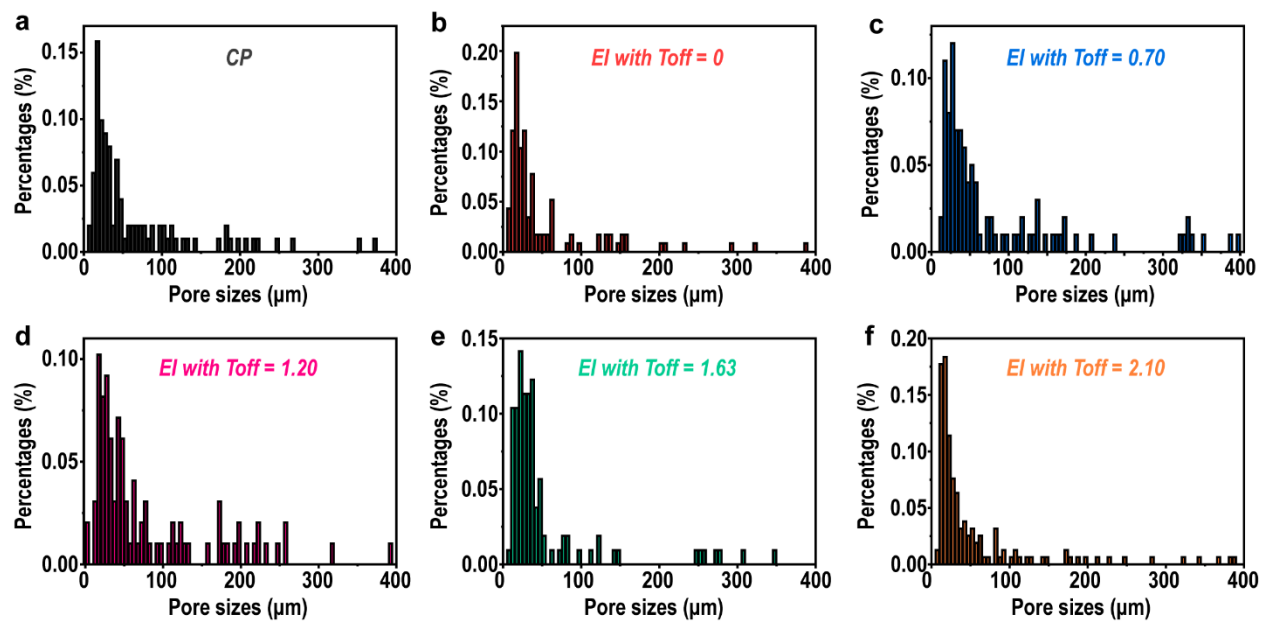


**Supplementary Fig. 2.** Densities of all PBfs fabricated in this work.

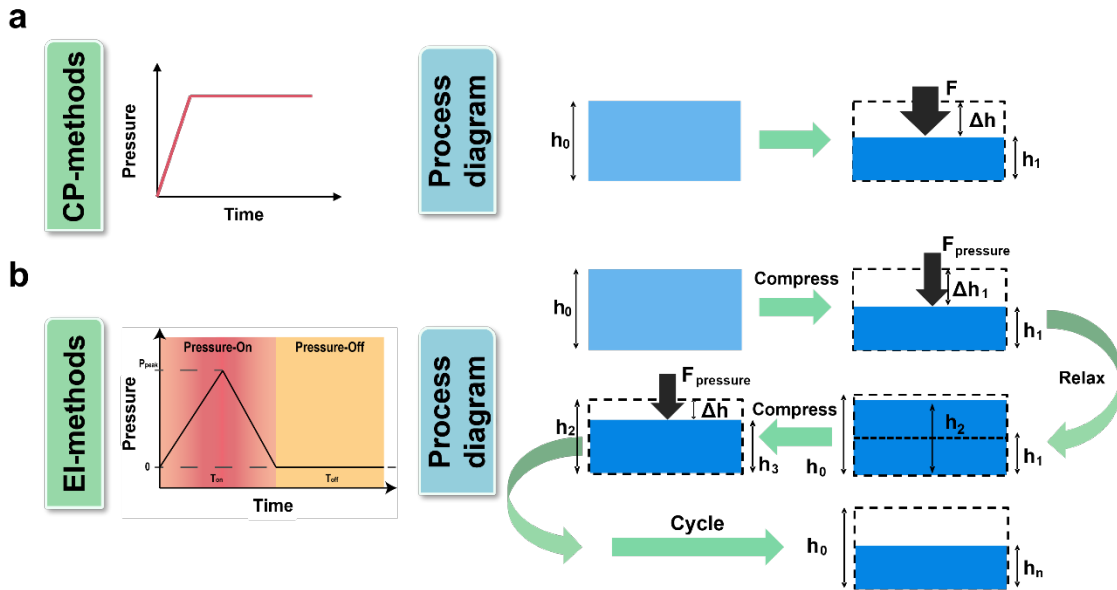


**Supplementary Fig. 3.** Porosities of all PBfs fabricated in this work.

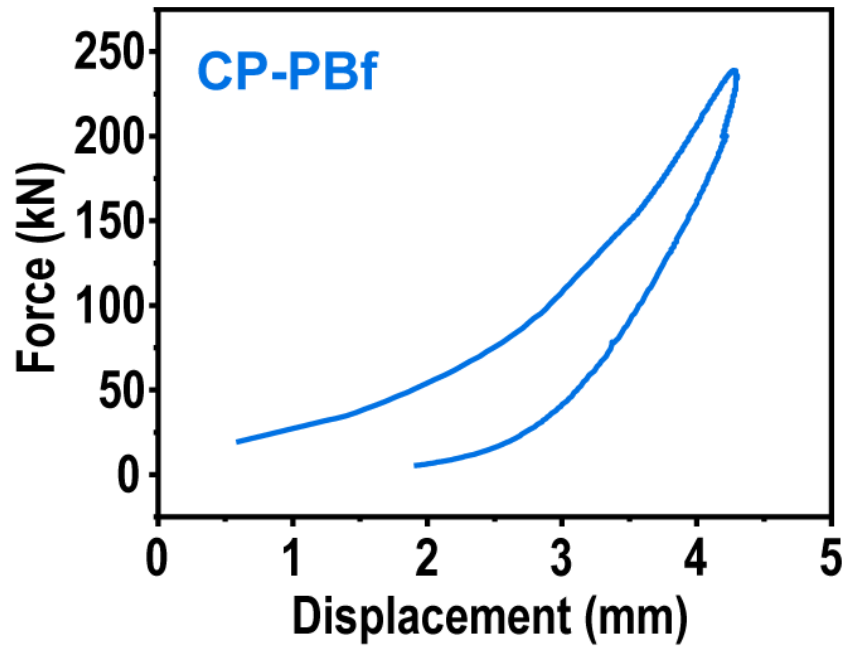




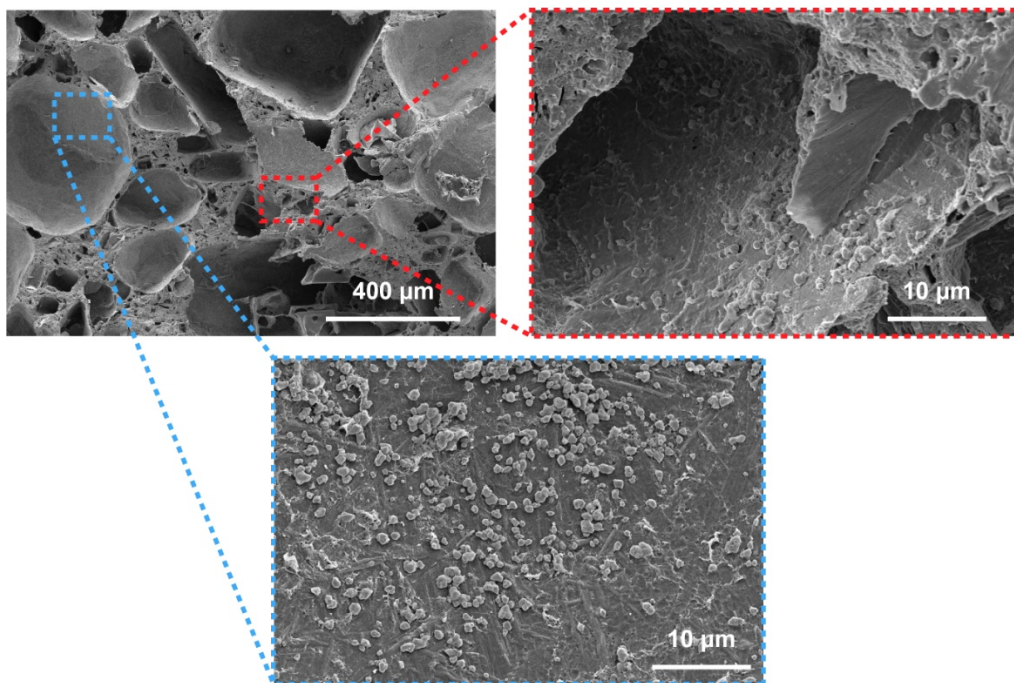
**Supplementary Fig. 4.** Pore sizes of all PBfs fabricated in this work. The distributions of pore size of PBfs fabricated with different Toff, (a) CP, (b) Toff = 0, (c) Toff = 0.70, (d) Toff = 1.20, (e) Toff = 1.63, (f) Toff = 2.10.



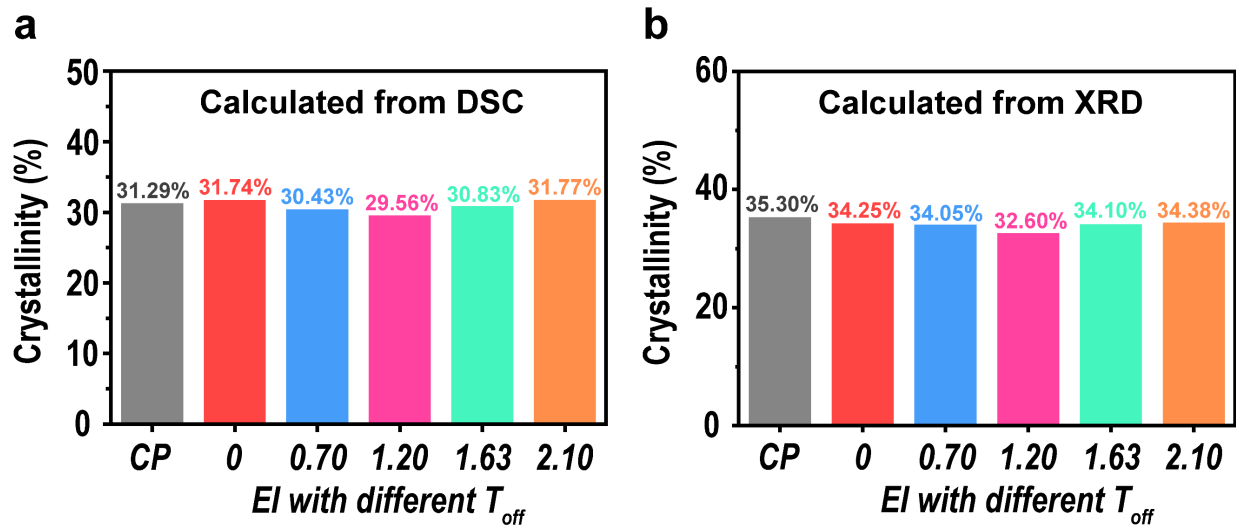
**Supplementary Fig. 5.** Illustration of the different response of materials under (a) CP- and (b) EI-methods.



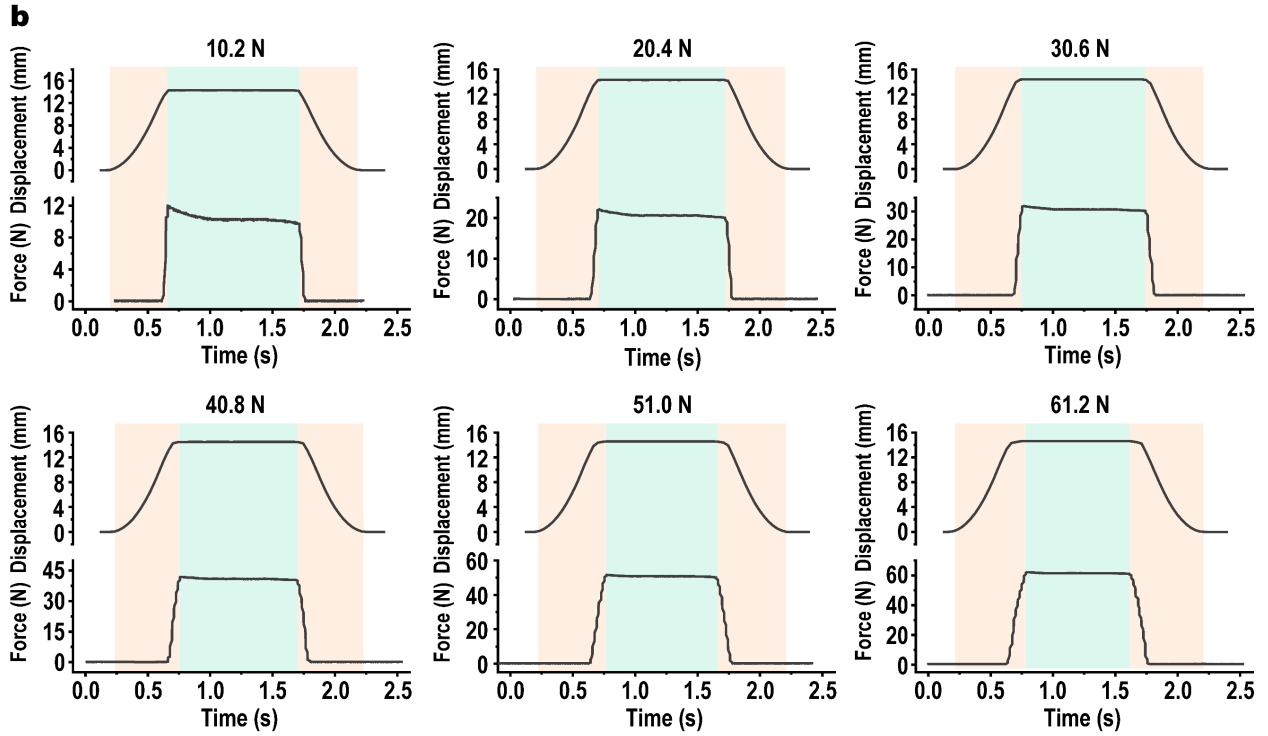
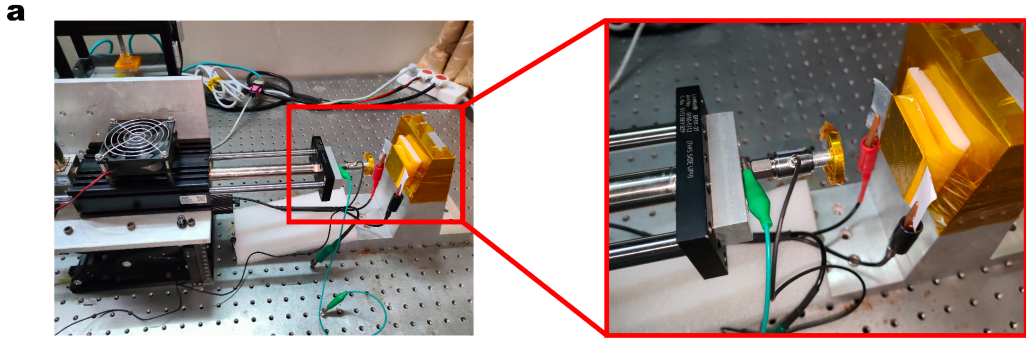
**Supplementary Fig. 6.** Compression force-delta thickness relationship of CP-PBf.



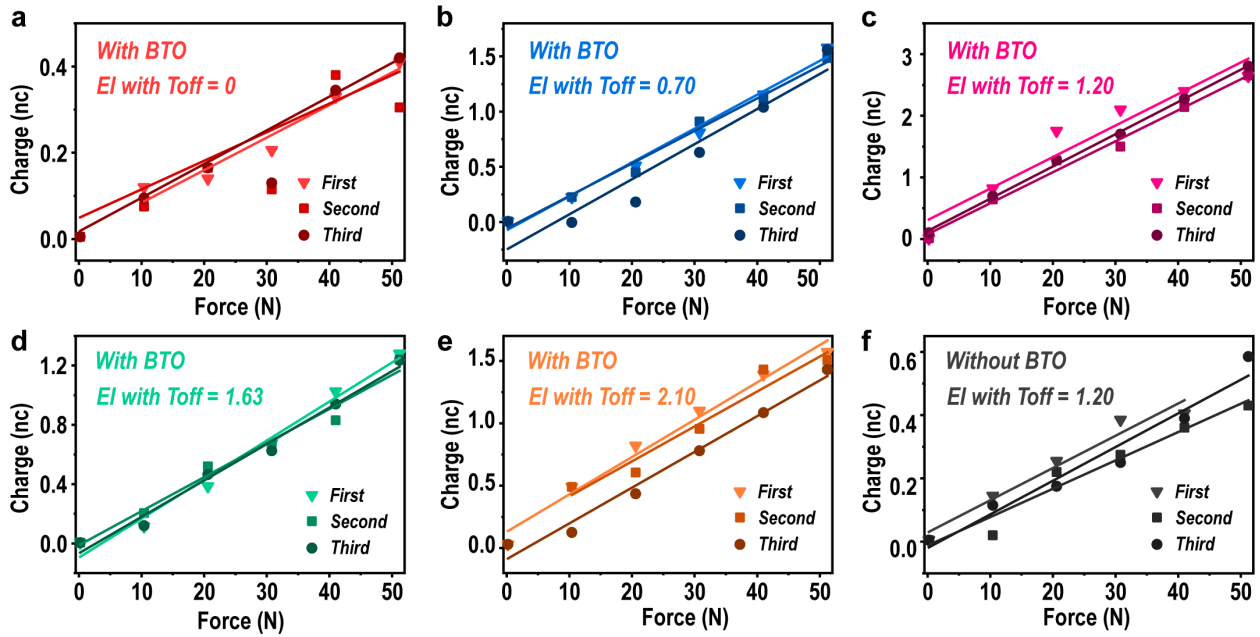
**Supplementary Fig. 7.** SEM images of CP-PBf.



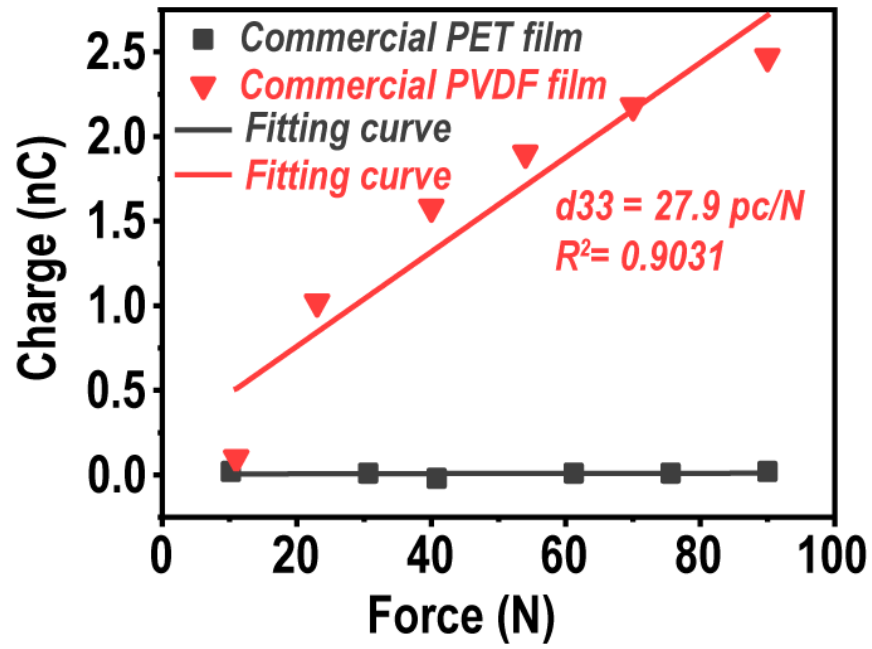
Supplementary Fig. 8. Crystallinities of each sample calculated *via* (a) DSC and (b) XRD.



**Supplementary Fig. 9.** (a) Photographs of the setup for piezoelectric tests, and (b) Applied force-displacement waveform for the piezoelectric tests.

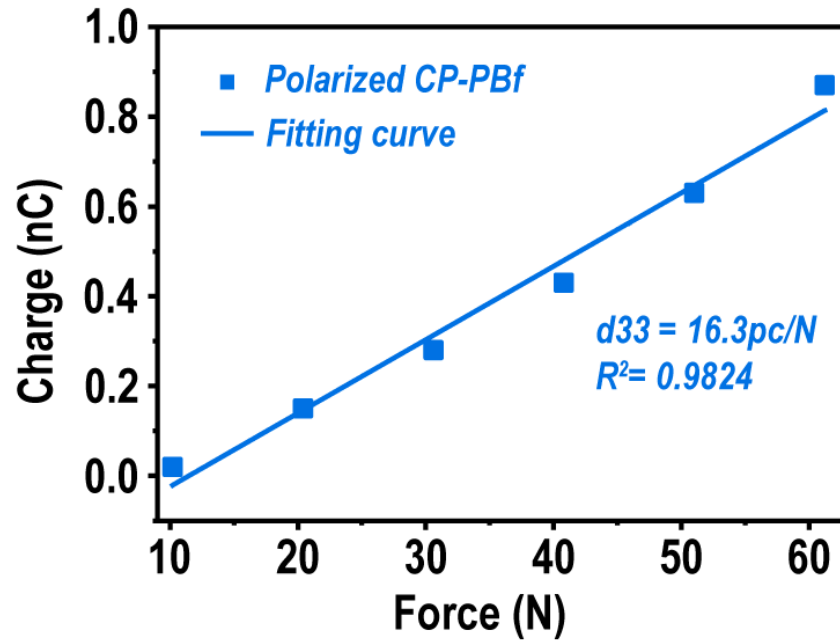


**Supplementary Fig. 10.** Charge vs force relationship of each sample for piezoelectric output measurement. The Charge vs force relationship of three repeated tests corresponding to PBfs, (a) ToFF = 0, (b) ToFF = 0.70, (c) ToFF = 1.20, (d) ToFF = 1.63, (e) ToFF = 2.10. (f) The Charge vs force relationship of three repeated tests of Pfs (the BTO free samples) with ToFF = 1.20.

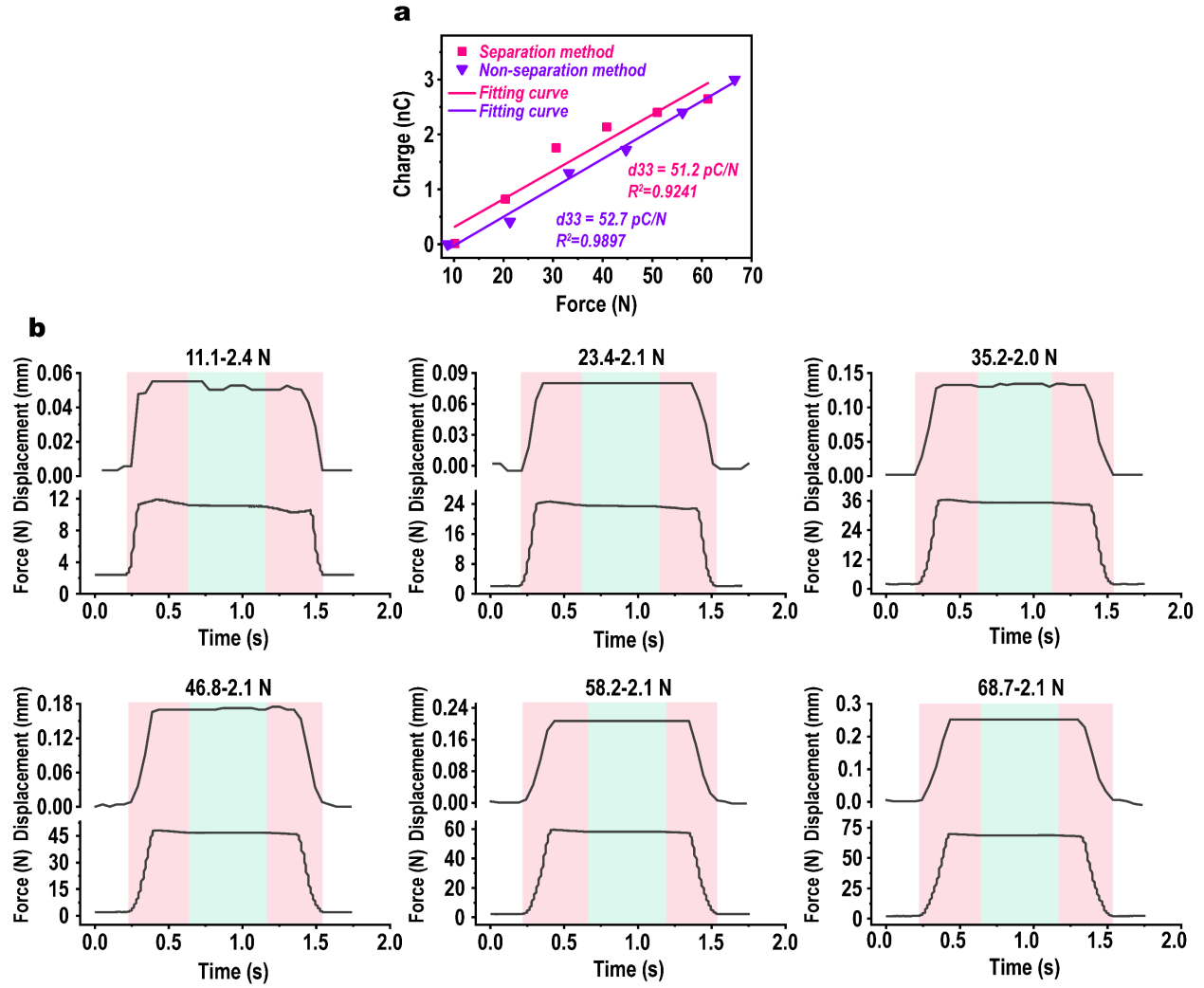


Supplementary Fig. 11.  $d_{33}$  of commercial poled-PVDF film and non-piezoelectric PET film.





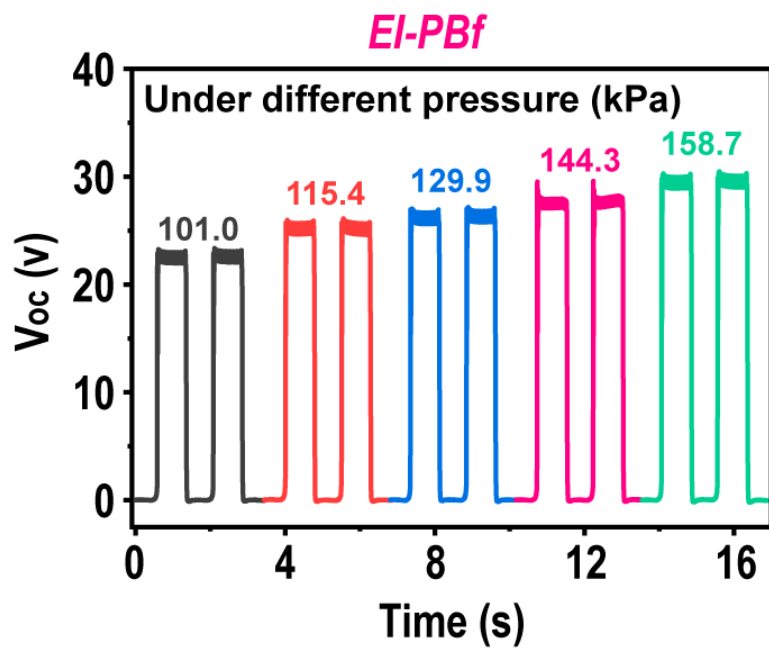
Supplementary Fig. 12.  $D_{33}$  of electrical-poled CP-PBf.



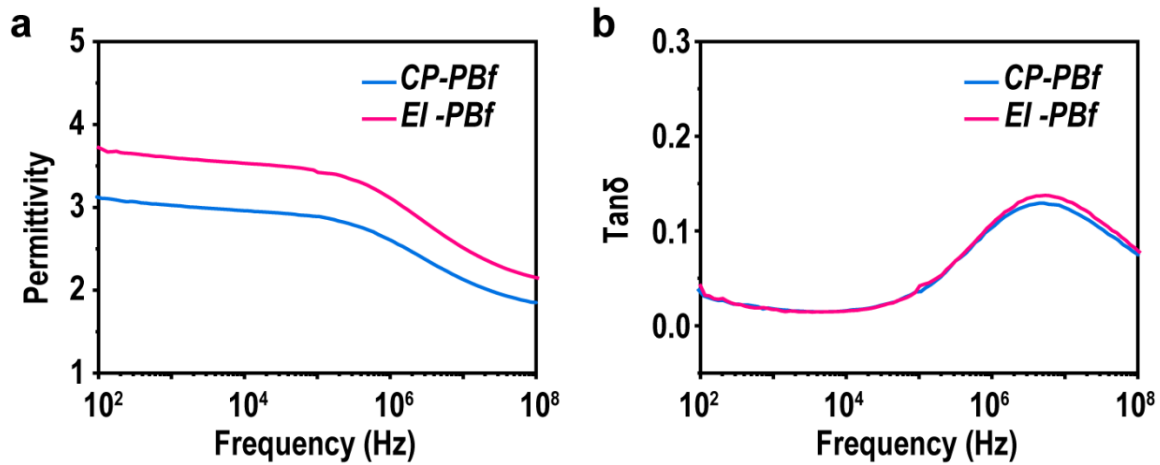
**Supplementary Fig. 13.** (a) The charge-force relationship of our EI-PBf measured using a separation method and a non-separation method, and (b) applied force / displacement waveform for the non-separation piezoelectric test.



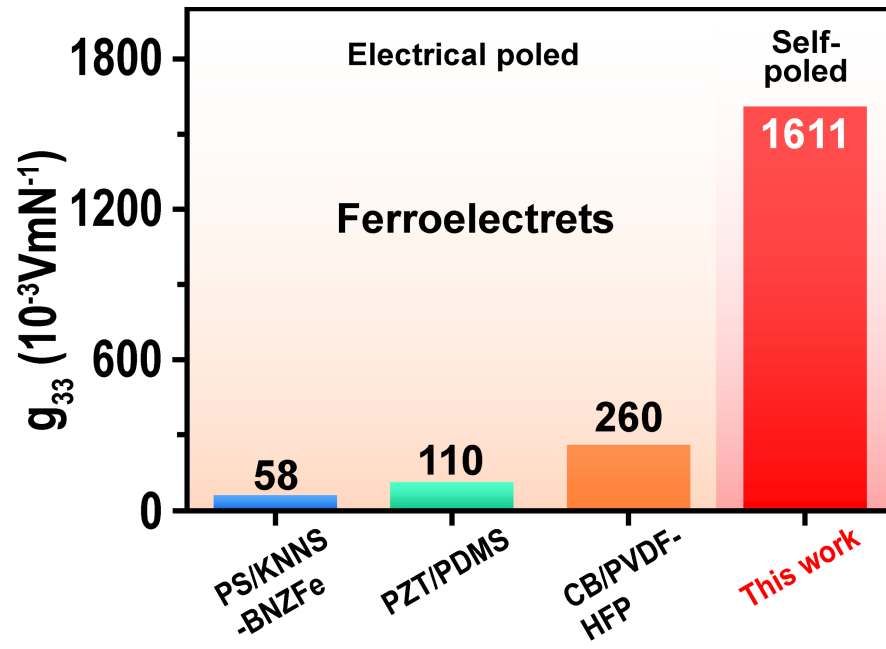
**Supplementary Fig. 14.** D33 meter test results of EI-PBf sample.



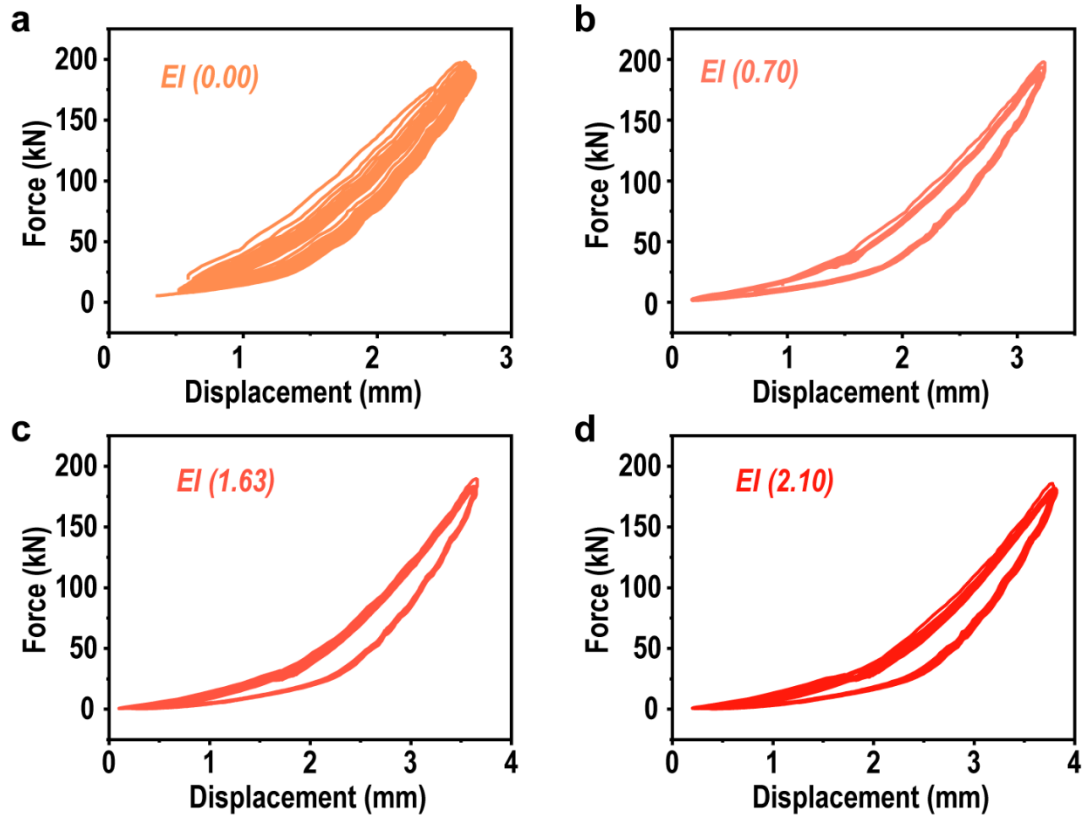
**Supplementary Fig. 15.** The Voc of EI-PBf under higher applied pressures.



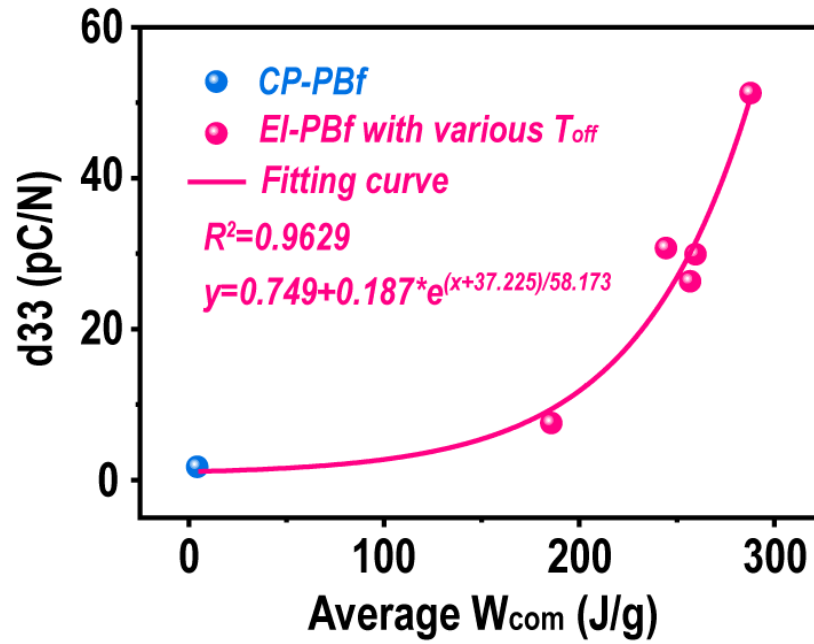
**Supplementary Fig. 16.** Dielectric properties of CP- and EI-PBfs. Frequency dependence of (a) dielectric constant and (b) dielectric loss tangent of CP-PBf and EI-PBf.



**Supplementary Fig. 17.** Comparison of the  $g_{33}$  value between our self-poled sample and reported electrical poled ferroelectrets.

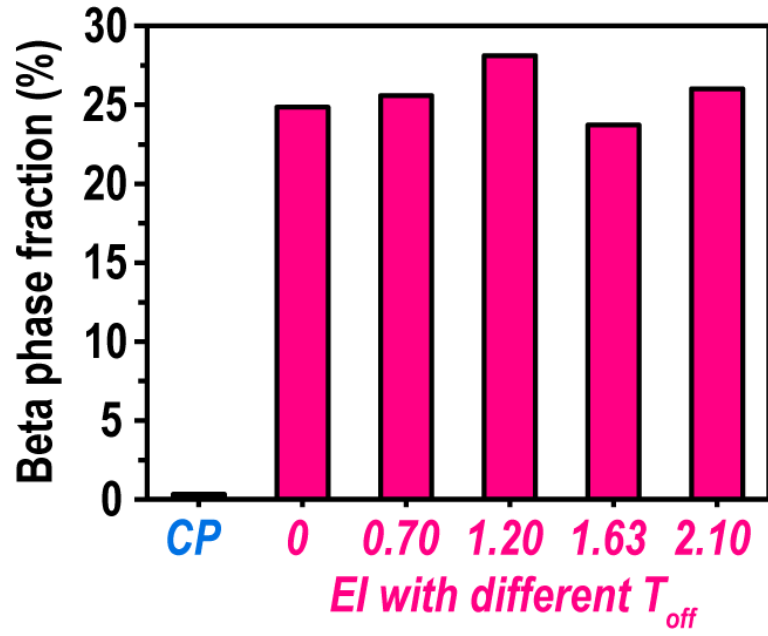


**Supplementary Fig. 18.** Force-displacement relationships of EI-PBf with various  $T_{off}$ . The Force-displacement relationships of 119 repeated machining operations corresponding to PBfs, (a)  $T_{off} = 0$ , (b)  $T_{off} = 0.70$ , (c)  $T_{off} = 1.63$ , (d)  $T_{off} = 2.10$ .



**Supplementary Fig. 19.** The functional relationship between d33 and average W<sub>com</sub> in CP-PBf and EI-PBf with various T<sub>off</sub>.





**Supplementary Fig. 20.** The  $\beta$ -phase of each sample with various  $T_{off}$ .

**Supplementary Table 1.** The d<sub>33</sub>, g<sub>33</sub> and FOM of CP- and EI-PBf compared with other inorganic crystals and ceramics, polymers, organic crystals and hybrid crystals.

Compound	d <sub>33</sub> (pC/N)	g <sub>33</sub> (10 <sup>-3</sup> VmN- 1)	g <sub>33</sub> <sup>ds</sup> (m·VPa- 1g-1)	FOM (10 <sup>-15</sup> m <sup>2</sup> /N)	Referen ce	
PVDF/BiTiO <sub>3</sub>	51.2	1611	25020	198105	This work	
Composite materials	Ti <sub>3</sub> C <sub>2</sub> T <sub>x</sub> /Sm- PMN-PT/PVDF	65	253	1950	16462	6
	PVDF-TrFE- Ti <sub>3</sub> C <sub>2</sub> T <sub>x</sub>	52	402	2700	20904	7
	PZT/PDMS	78	881	-	68718	8
	PZT/Resin	29	37	-	1073	9
	(ATHP) <sub>2</sub> PbBr <sub>4</sub>	76	660	2600	50160	10
Hybrids	TMBM-MnBr <sub>3</sub>	112	1120	-	125440	11
	TMCM-GaCl <sub>4</sub>	226	1318	-	297868	12
	TMCM-MnCl <sub>3</sub>	185	1681	9160	310985	13
	PVDF	33	310	-	10254	14
polymers	BOPVDF	62	359	1970	22274	15
	P(VDFTrFE)	25	237	-	5934	16
	(β-CN)APB/ODPA	16.5	533	-	8789	17
	BaTiO <sub>3</sub>	191	11	-	2172	18
Inorganics	PbTiO <sub>3</sub>	143	129	-	19367	19
	PIN-PMN-Pt	1100	33	-	36949	20
	PZT-5A	440	25	-	11000	21

**Supplementary Table 2.** Piezoelectric properties of our EI-PBf and other reported ferroelectrets materials.

Sample	d33 (pc/N)	g33( $10^{-3}$ VmN $^{-1}$ )	FOM ( $10^{-15}$ m $^2$ N $^{-1}$ )	References
PS/KNNS-BNZFe	400	58	20887	22
PZT/PDMS	497	110	54218	23
CB/PVDF-HFP	58	260	15080	24
This work	51	1611	82541	

**Supplementary Table 3.** Crystal data and structure refinement of CP- and EI-PBf.

Compound	CP-PBf	EI-PBf
Formula	PVDF	PVDF/BaTiO <sub>3</sub>
System	Tetragonal	Tetragonal
Space group	P4mm	P4mm
<i>a</i> (Å)	3.99311	4.00073
<i>b</i> (Å)	3.99311	4.00073
<i>c</i> (Å)	4.03457	4.04584
$\alpha$ (°)	90	90
$\beta$ (°)	90	90
$\gamma$ (°)	90	90
<i>V</i> (Å <sup>3</sup> )	64.331	64.757
Ti (Å)	0.51848	0.43668
O1 (Å)	0.10908	0.10224
O2 (Å)	0.59701	0.45601
R <sub>p</sub>	5.35	6.31
R <sub>wp</sub>	7.09	8.33
Chi <sup>2</sup>	3.82	5.63

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